

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 109725.01	APPLICATION NO. Rule 53(b) Divisional of Application No. 09/857,803 <u>10/684,874</u>		
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Hiroji AGA et al.			
				FILING DATE October 15, 2003			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME		CLASS	SUB CLASS
<i>AGA</i>		US-2002/0127820	09-2002	Nobuhiko SATO			
<i>AGA</i>		5,989,981	11-1999	NAKASHIMA et al.			
<i>AGA</i>		6,350,703	02-2002	SAKAGUCHI et al.			
<i>AGA</i>		6,074,479 A	06-2000	ADACHI et al.			
<i>AGA</i>		6,403,502 B1	06-2002	KOBAYASHI et al.			
<i>AGA</i>		6,261,362 B1	07-2001	FUJIKAWA et al.			
<i>AGA</i>		6,313,014 B1	11-2001	SAKAGUCHI et al.			
<i>AGA</i>		5,937,312 A	08-1999	IYER et al.			
<i>AGA</i>		5,834,812 A	11-1998	GOLLAND et al.			
<i>AGA</i>		6,284,628 B1	09-2001	KUWAHARA et al.			
<i>AGA</i>		6,103,599 A	08-2000	HENLEY et al.			
<i>AGA</i>		6,312,797 B1	11-2001	YOKOKAWA et al. <i>↳ same</i>			
<i>AGA</i>		5,863,832 A	01-1999	DOYLE et al.			
<i>AGA</i>		6,238,990 B1	05-2001	AGA et al.			
<i>AGA</i>		6,312,797 B1	11-2001	YOKOKAWA et al.			
<i>AGA</i>		6,224,668 B1	05-2001	Masaro TAMATSUKA			
<i>AGA</i>		6,284,629 B1	09-2001	YOKOKAWA et al.			
<i>AGA</i>		6,140,210 A	10-2000	AGA et al.			
<i>AGA</i>		6,245,645 B1	06-2001	MITANI et al.			
<i>AGA</i>		6,251,754 B1	06-2001	OHSHIMA et al.			
<i>AGA</i>		5,668,045 A	09-1997	GOLLAND et al.			
<i>AGA</i>		5,494,849 A	02-1996	IYER et al.			

FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
<i>MPE</i>		JP A 10-242154 (w/ Abstract)	09/11/1998	Japan			
<i>MPE</i>		JP A 10-275905 (w/ Abstract)	10/13/1998	Japan			
<i>MPE</i>		JP A 10-335616 (w/ Abstract)	12/18/1998	Japan			
<i>MPE</i>		JP A 11-191617 (w/ Abstract)	07/13/1999	Japan			
<i>MPE</i>		JP A 11-145436 (w/ Abstract)	05/28/1999	Japan			
<i>MPE</i>		JP A 11-186277 (w/ Abstract)	07/09/1999	Japan			
<i>MPE</i>		JP A 8-264552 (w/ Abstract)	10/11/1996	Japan			
<i>MPE</i>		JP A 7-321120 (w/ Abstract)	12/08/1995	Japan			
<i>MPE</i>		JP 2000-012864 A	01-2000	Japan			
<i>MPE</i>		JP 11-316154 A	11-1999	Japan			
<i>MPE</i>		DE 19753494 A1	10-1998	Germany			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
<i>MPE</i>	Stanley WOLF, "silicon Processing for the VLSI Era", Vol. 1, Lattice Press, 1986, pgs. 23-25.						
EXAMINER	<i>Michelle Estrada</i>				DATE CONSIDERED		
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: October 15, 2003